

REPLY UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 1700

Attorney's Docket No. 042390.P6148D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:

Kevin J. Lee

Serial No. 10/808,763

Filed: March 24, 2004

For: CONTROLLED POTENTIAL ANODIC ETCHING
PROCESS FOR THE SELECTIVE REMOVAL OF
CONDUCTIVE THIN FILMS

Examiner: Lois L. Zheng

Art Unit: 1742

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Ma'am:

In response to the Final Office Action dated May 30, 2007, please amend the above-captioned application as set forth below.

Amendments to the Claims are reflected in the listing of claims and begins on page 2 of this response.

Remarks/Arguments begin on page 3 of this response.

Not Entered
